

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Pa	atent Application of	
Michae	el STEIGERWALD, et al.	Group Art Unit: 2881
Applica	ation No.: 10/825,240	Examiner:
Filed:	April 16, 2004	Confirmation No.: 7784
For:	ELECTRON MICROSCOPY SYSTEM, ELECTRON MICROSCOPY METHOD AND FOCUSING SYSTEM FOR CHARGED PARTICLES	

FIRST INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, the accompanying information is being submitted in accordance with 37 C.F.R. §§ 1.97 and 1.98.

Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed. However, copies of the listed U.S. patents and U.S. patent application publications are not enclosed since it is no longer required according to the July 11, 2003 waiver of the requirement for copies of cited U.S. patents and U.S. patent application publications in national patent applications filed after June 30, 2003 and international applications entering the national stage under 35 U.S.C. § 371 after June 30, 2003.

The documents are being submitted within three (3) months of the filing or entry of the national stage of this application or before the first Office Action on the merits, whichever is later. Since these documents are being filed within the time period set forth in 37 C.F.R. § 1.97(b), no fee or statement is required.

Certain documents listed on the attached PTO-1449 are foreign language documents. The undersigned has been informed that the following foreign language documents correspond to U.S. Patent documents:

FOREIGN DOCUMENT		CORRESPONDING U.S. PATENT
EP 0 180 723-A1	Corresponds to	US 4,713,543
EP 0 242 602-A2	Corresponds to	US 4,785,176
EP 0 274 622-A1	Corresponds to	US 4,831,266
EP 0 333 018 -A2	Corresponds to	US 4,926,054
DE 38 39 707-A1	Corresponds to	US 5,041,724
JP 02-213037-A	Corresponds to	US 5,041,724
DE 29 22 325-A1	Corresponds to	US 4,330,707
EP 0 205 184-A2	Corresponds to	US 4,728,790
DE 36 38 682 -A1	Corresponds to	US 4,812,651
EP 0 281 743-A2	Corresponds to	US 4,896,036
DE 37 03 028-A1	Corresponds to	US 4,896,036
EP 0 428 906-A2	Corresponds to	US 5,061,856
EP 0 461 442-A2	Corresponds to	US 5,146,090
DE 196 05 855-A1	Corresponds to	US 5,780,859
EP 0 910 108-A1	Corresponds to	US 6,107,633
EP 0 910 109-A1	Corresponds to	US 6,104,034
DE 102 17 507-A1	Corresponds to	US 6,737,647 B1

With regard to SU 997135, please see the figure in the document.

To further assist the Examiner, documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

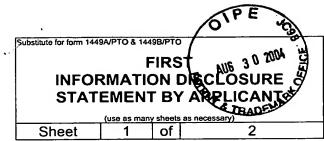
Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

Date August 30, 2004

Douglas H. Pearson Registration No. 47,851

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Com	plete if Known			
Application Number 10/825,240				
Filing Date	April 16, 2004			
First Named Inventor	STEIGERWALD, et al.			
Examiner Name	Unassigned			
Attorney Docket Number 007413-076				

			U.S. PATENT DOCUMENTS	
Examiner Initials	Document Number	Kind Code (if known)	Name of Patentee or Applicant of Cited Document	Issue/Publication Date (MM-DD-YYYY)
	4,713,543		FEUERBAUM, et al.	12-15-1987
	4,785,176		FROSIEN, et al.	11-15-1988
	4,831,266		FROSIEN, e t al.	05-16-1989
	4,926,054		FROSIEN	05-15-1990
	5,041,724		FEUERBAUM, et al.	08-20-1991
	4,330,707	-	MANZKE	05-18-1982
	4,728,790		PLIES	03-01-1988
	4,812,651		FEUERBAUM, et al.	03-14-1989
· · · ·	4,896,036		ROSE, et al.	01-23-1990
	5,061,856		FROSIEN, et al.	10-29-1991
	5,146,090		PLIES	09-08-1992
	5,677,530		SATO, et al.	10-14-1997
	5,780,859		FEUERBAUM, et al.	07-14-1998
	5,847,399		SCHMITT, et al.	12-08-1998
··-	5,895,917		UEDA, et al.	04-20-1999
	5,808,309		SPEHR, et al.	09-15-1998
	6,051,838		FROSIEN, et al.	04-18-2000
	6,107,633	-	FROSIEN, et al.	08-22-2000
	6,104,034		FROSIEN, et al.	08-15-2000
	6,232,601	B1	SCHMITT, et al.	05-15-2001
	6,037,589		YONEZAWA, et al.	03-14-2000
	4,464,571		PLIES	08-07-1984
	2002/0130262	A1	NAKASUJI, et al.	09-19-2002
	4,780,682		POLITZER	10-25-1988
	2,354,287		ZWORYKIN, et al.	07-25-1944
-	2,661,427		PAGE	12-01-1953
	6,310,341	B1	TODOKORO, et al.	10-30-2001
	6,737,647	B2	SCHÖNHENSE, et al.	05-18-2004

FOREIGN PATENT DOCUMENTS											
STATUS							-				
Examiner Initials	Document Number	Kind Code (if known)	Country	Date of Publication (MM-DD-YYYY)	Translation	Partial Translation	Eng. Lang. Summary	Search Report	IPER	Abstract	Cited in Spec
-	EP 0 180 723	A1	EUROPE	05-14-1986					104		
	EP 0 242 602	A2	EUROPE	10-28-1987							
	EP 0 274 622	A1	EUROPE	07-20-1988							
	EP 0 333 018	A2	EUROPE	09-20-1989							
	DE 38 39 707	A1	GERMANY	05-31-1990							
	JP 02-213037	Α	JAPAN	08-24-1990							
	DE 29 22 325	A1	GERMANY	12-11-1980				7	C.		
	EP 0 205 184	A2	EUROPE	12-17-1986							
	DE 36 38 682	A1	GERMANY	05-19-1988							
	EP 0 281 743		EUROPE	09-14-1988		1					
	DE 37 03 028	A1	GERMANY	09-01-1988		1					

Examiner Signature

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

Substitute for form 1449A/PTO & 1449B/PTO				Complete if Known				
		FIRS	ST.	Application Number	10/825,240			
INFO	RMATI	ON I	DISCLOSURE	Filing Date	April 16, 2004			
			APPLICANT	First Named Inventor	STEIGERWALD, et al.			
	(use as man	v sheets	s as necessary)	Examiner Name	Unassigned			
Sheet	2	of	2	Attorney Docket Number	007413-076			

		FOREIGN PATENT DO	CUMENTS		
EP 0 428 906	A2	EUROPE	05-29-1991		\top
EP 0 461 442	A2	EUROPE	12-18-1991		
EP 0 762 468	A1	EUROPE	03-12-1997		
EP 0 790 634	A1	EUROPE	08-20-1997		m f L
DE 196 05 855	A1	GERMANY	08-21-1997		T
EP 0 821 392	A1	EUROPE	01-28-1998		T
EP 0 821 393	A1	EUROPE	01-28-1998		Τ
EP 0 834 896	A1	EUROPE	04-08-1998		T.
EP 0 834 335	A1	EUROPE	05-20-1998		T.
EP 0 910 108	A1	EUROPE	04-21-1999		Τ
EP 0 910 109	A1	EUROPE	04-21-1999		
EP 0 952 606	A1	EUROPE	10-27-1999		Т
SU 997135	A1	SOVIET UNION	02-15-1983		T
DE 102 17 507	A1	GERMANY	11-13-2003		T
					Т

NON-PATENT LITERATURE DOCUMENTS							
Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.						
	LAURENCE C. OLDFIELD, "Computer Design of High Frequency Electron-Optical System", Image						
	Processing and Computer-Aided Design, Electron Optics, P.W. Hawkes, Ed., Academic Press, London,						
	1973, pgs. 370-399						
	JIN-ICHI MATSUDA, et al., "Calculations of the Aberration Properties of the TM ₀₁₀ Mode RF-fields Electron Lens", No. 1236, 1975						
	G. SCHÖNHENSE, et al., "Chromatic and Spherical Aberration Correction Using Time-Dependent Acceleration and Lens Fields", Microsc. Microanal. 9 (Suppl. 3), 2003, pgs. 34-35, DOI 10.1017/S1431927603011188						

Examiner	Date	
Signature	Considered	